INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 30, 2026

IGI Report Number	LG842612644
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	9.34 - 9.40 X 5.51 MM

GRADING RESULTS

Carat Weight	2.95 CARATS
Color Grade	E
Clarity Grade	VS 2
Cut Grade	IDEAL

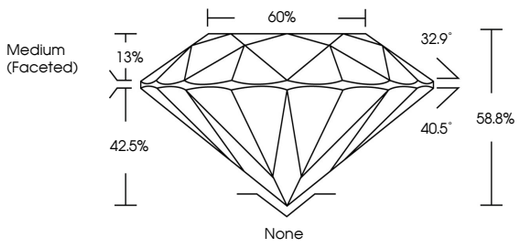
ADDITIONAL GRADING INFORMATION

Polish	VERY GOOD
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG842612644

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG842612644
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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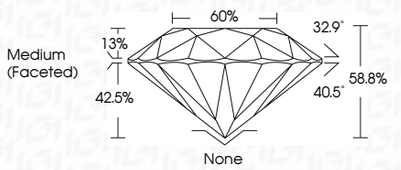
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IGI

September 30, 2026
IGI Report No LG842612644
ROUND BRILLIANT
9.34 - 9.40 X 5.51 MM
Carat Weight 2.95 CARATS
Color Grade E
Clarity Grade VS 2
Cut Grade IDEAL
Depth 58.8%
Table 60%
Girdle Medium (Faceted)
Culet None
Polish VERY GOOD
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG842612644
Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa